

WENDEROTH, LIND & PONACK, L.L.P.

2033 K Street, N.W., Suite 800

Washington, D.C. 20006

Phone: (202) 721-8200

Facsimile: (202) 721-8250

FAX TRANSMITTAL COVER SHEET

Date: 8/18/03To: Ex. Sylvia MacArthurCompany Name: U.S. p40Fax Number: (703) 872-9630From: Charles R. Watts #33142Message: Re: Kimura 09/1742,386
Here is the election of 4/7/03, and the postcard
Thank YouTotal Number of Pages Transmitted, Including Cover Sheet: (3) 3

CONFIDENTIALITY

The documents transmitted herewith may contain confidential and/or privileged information intended only for the use of the person or entity to whom addressed. If you are not the intended recipient, or an agent of the recipient responsible for delivering it to the intended recipient, then you have received this transmission in error and are asked to promptly advise us by telephone or fax, and return the document to us by mail. Unauthorized copying, distribution, disclosure or other use of this information by anyone other than the intended recipient or their designee is prohibited.

If there are any problems with this transmission
or if you have not received all of the pages
please call (202) 721-8200

Fax Operator: PAV

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : Confirmation No. 8728
Norio KIMURA et al. : Docket No. 2000-1761A
Serial No. 09/742,386 : Group Art Unit 1763
Filed December 22, 2000 : Examiner Sylvia MacArthur

APPARATUS AND METHOD FOR
PROCESSING SEMICONDUCTOR
SUBSTRATE

ELECTION OF INVENTION

Assistant Commissioner for Patents,
Washington, D.C.

Sir:

In response to the Office Action of March 7, 2003, Applicants in the above-referenced patent application hereby elect group I corresponding to claims 1-45 and 51-72, drawn to a semiconductor processing apparatus.

An early and favorable action on the merits is requested.

Respectfully submitted,

Norio KIMURA et al.

By: *[Signature]* #33142 /copy

Nils E. Pedersen

Registration No. 33,145

Attorney for Applicants

NEP/krl

Washington, D.C. 20006-1021

Telephone (202) 721-8200

Facsimile (202) 721-8250

AUG. 18. 2003 2:28PM

WENDEROTH LIND & PONACK

NO. 8666 P. 3

ATTY DOCKET #: 2000-1761A

Due Date: April 7, 2003

Confirmation No. 8728

OUR REF: 2000-1761A/NEP/01213

Applicant: Norio KIMURA et al.

Serial No.: 09/742,386 Filing Date: December 22, 2000

Title: APPARATUS AND METHOD FOR PROCESSING SEMICONDUCTOR
SUBSTRATE

Receipt of the following papers is acknowledged:

1. Election of Invention



Date: April 7, 2003

Attorney: NEP/krl

[Check No. N/A]